

# Poster Program

Poster session (November 15, 12:10-13:40)

**P1**

**“Near-infrared sensitivity improvement of thin InGaAs photodetector with Au grating for high-speed optical communication”**

Toshiki Masuzawa<sup>1</sup>, Atsushi Ono<sup>1</sup>

<sup>1</sup>Shizuoka University

**P2**

**“Computational Modeling and Machine Learning of Semiconductor Materials and Processes”**

Ian Kerby<sup>1</sup>, Lan Li<sup>1</sup>

<sup>1</sup>Micron School of Materials Science and Engineering, Boise State University

**P3**

**“Evaluation of the GaN HEMT with Floating Gate to Improve Breakdown Voltage”**

Hayato Kosaka<sup>1</sup>, Takao Okuno<sup>1</sup>, Iori Shinke<sup>1</sup>, Riichiro Shirota<sup>2</sup>, Yoshiteru Amemiya<sup>3</sup>, Akinobu Teramoto<sup>1,3,4</sup>

<sup>1</sup>Graduate School of Advanced Science and Engineering, Hiroshima University, <sup>2</sup>College of Semiconductor Research, National Tsing Hua University, <sup>3</sup>Research Institute for Semiconductor Engineering, Hiroshima University, <sup>4</sup>Research Institute for Synchrotron Radiation Science, Hiroshima University

**P4**

**“Investigation of the impact of dumping-like torque by inserting Gd-CoFeB alloy at the W/CoFeB interface”**

Kazuhiko Tokunaga<sup>1</sup>, Yuichiro Kurokawa<sup>1</sup>, Hiromi Yuasa<sup>1</sup>

<sup>1</sup>Graduate School and Faculty of Information Science and Electrical Engineering, Kyushu University

**P5**

**“Optimized insertion of Co-layers on the magnetic properties of Mn<sub>1.5</sub>Ga/MgO system”**

Nur Amirah Zahrin<sup>1</sup>, Kazuhiko Tokunaga<sup>1</sup>, Yuichiro Kurokawa<sup>1</sup>, Hiromi Yuasa<sup>1</sup>

<sup>1</sup>Kyushu University

**P6**

**“Development of a time-resolved system using a microfluidic channel for observing the conformational changes of proteins”**

Satoshi Hashimoto<sup>1</sup>, Koichi Matsuo<sup>1,2,3</sup>

<sup>1</sup>Graduate School of Advanced Science and Engineering, Hiroshima University, <sup>2</sup>Research Institute for Synchrotron Radiation Science, Hiroshima University, <sup>3</sup>International Institute for Sustainability with Knotted Chiral Meta Matter (WPI-SKCM2), Hiroshima University

**P7**

**“Coupling of Self-Generated Spin Waves and Spin Transfer Torque Driven Oscillations in Biquadratic Coupled Orthogonal Magnetization Disks”**

Tsz Chung Cheng<sup>1</sup>, Chuhan Liu<sup>1</sup>, Yuichiro Kurokawa<sup>1</sup>, Hiromi Yuasa<sup>1</sup>

<sup>1</sup>Graduation School and Faculty of Information Science and Electrical Engineering, Kyushu University

**P8**

**“Investigation of the Electronic Band Structure of Altermagnetic Semiconductor MnTe (0001) Using ARPES”**

Kazi Golam Martuza<sup>1</sup>

<sup>1</sup>Graduate School of Advanced Science and Engineering, Hiroshima University

**P9**

**“Development of high-efficiency spin- and angle-resolved photoemission spectrometer at HiSOR”**

Kazuki Sumida<sup>1</sup>, Takuma Iwata<sup>2,3</sup>, Takahito Takeda<sup>2</sup>, Akio Kimura<sup>2,3,4</sup>, Kenta Kuroda<sup>2,3,4</sup>, Koji Miyamoto<sup>1</sup>, Taichi Okuda<sup>1,3,4</sup>

<sup>1</sup>Research Institute for Synchrotron Radiation Science (HiSOR), Hiroshima University, <sup>2</sup>Graduate School of Advanced Science and Engineering, Hiroshima University, <sup>3</sup>International Institute for Sustainability with Knotted Chiral Meta Matter (WPI-SKCM2), Hiroshima University, <sup>4</sup>Research Institute for Semiconductor Engineering (RISE), Hiroshima University

**P10**

**“Compositional analysis of highly-doped silicon-on-insulator thin films for nanodevices”**

Taichi Hirano<sup>1</sup>, Shun Masui<sup>1</sup>, Reon Asai<sup>1</sup>, Baskoro Arif Rianto<sup>1</sup>, Daniel Moraru<sup>1,2</sup>

<sup>1</sup>Graduate School of Integrated Science and Technology, Shizuoka University, <sup>2</sup>Research Institute of Electronics, Shizuoka University

**P11**

**“Resist stripping with High Concentration O<sub>3</sub>-Water”**

Kengo Yamada<sup>1</sup>, Takayuki Jizaimaru<sup>1</sup>

<sup>1</sup>Nomura Micro Science Co., Ltd., <sup>2</sup>Nomura Micro Science Co., Ltd.

**P12**

**“Observation of Spin Seebeck Effect in YIG/Pt-Rh”**

Shuto Sahara<sup>1</sup>, Yuichiro Kurokawa<sup>1</sup>, Hiromi Yuasa<sup>1</sup>

<sup>1</sup>*Kyushu University*

**P13**

**“Write Error Rate of Magnetic Tunnel Junction with Intermediate State”**

Chihiro Watanabe<sup>1</sup>, Yuya Miyazaki<sup>1</sup>, Junichi Tsuchimoto<sup>2</sup>, Hiroyuki Hosoya<sup>3</sup>, Kazuto Yamanaka<sup>3</sup>, Yoshiteru Amemiya<sup>2</sup>, Akinobu Teramoto<sup>1,2,4</sup>

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**P14**

**“Evaluation of Switching Characteristics for Magnetic Tunnel Junction with Intermediate State”**

Yuya Miyazaki<sup>1</sup>, Chihiro Watanabe<sup>1</sup>, Junichi Tsuchimoto<sup>2</sup>, Hiroyuki Hosoya<sup>3</sup>, Kazuto Yamanaka<sup>3</sup>, Yoshiteru Amemiya<sup>2</sup>, Akinobu Teramoto<sup>1,2,4</sup>

<sup>1</sup>*Graduate School of Advanced Science and Engineering, Hiroshima University*, <sup>2</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*, <sup>3</sup>*CANON ANELVA Corporation*, <sup>4</sup>*Research Institute for Synchrotron Radiation Science, Hiroshima University*

**P15**

**“Study of silicon-on-insulator low-dimensional highly-doped pn diodes for clarification of band-to-band tunneling”**

Baskoro Arif Rianto<sup>1</sup>, Daris Alfafa<sup>2,3</sup>, Shun Masui<sup>1</sup>, Itsuki Yano<sup>4</sup>, Arief Udhiarto<sup>3</sup>, Daniel Moraru<sup>1,2,4,5</sup>

<sup>1</sup>*Graduate School of Integrated Science and Technology, Shizuoka University*, <sup>2</sup>*Graduate School of Science and Technology, Shizuoka University*, <sup>3</sup>*Department of Electrical Engineering, University of Indonesia*, <sup>4</sup>*Faculty of Engineering, Shizuoka University*, <sup>5</sup>*Research Institute of Electronics, Shizuoka University*

**P16**

**“A Skin Roughness Evaluation Method Focusing on Local Skin Surface Structure Using Deep Learning”**

Tatsuki Ohta<sup>1</sup>, Tetsushi Koide<sup>1</sup>, Kenta Nakamoto<sup>2</sup>, Yuki Hayashida<sup>2</sup>, Yumi Aoyama<sup>2</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*, <sup>2</sup>*Dermatology, Kawasaki Medical School*

**P17**

**“A Full-screen Real-time Diagnostic Support Method with Simultaneous Detecting and Classifying for Colonoscopy Lesion”**

Yongfei Wu<sup>1</sup>, Daisuke Katayama<sup>1</sup>, Tetsushi Koide<sup>1</sup>, Toru Tamaki<sup>2</sup>, Shigeto Yoshida<sup>3</sup>, Shin Morimoto<sup>4</sup>, Yuki Okamoto<sup>4</sup>, Shiro Oka<sup>4</sup>, Shinji Tanaka<sup>5</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*, <sup>2</sup>*Department of Computer Science, Nagoya Institute of Technology*, <sup>3</sup>*Department of Gastroenterology, Medical Corporation JR Hiroshima Hospital*, <sup>4</sup>*Department of Gastroenterology and Metabolism, Hiroshima University Hospital*, <sup>5</sup>*Department of Gastroenterology, JA Onomichi General Hospital*

**P18**

**“500°C Operation of Gate Driver Circuits Using 4H-SiC MOSFETs for High-Power Applications”**

Vuong Van Cuong<sup>1</sup>, Tatsuya Meguro<sup>1</sup>, Seiji Ishikawa<sup>2</sup>, Tomonori Maeda<sup>2</sup>, Hiroshi Sezaki<sup>2</sup>, Shin-Ichiro Kuroki<sup>1</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*, <sup>2</sup>*Phenitac Semiconductor Corp.*

**P19**

**“Solution-Processed 2D-Layered MoS<sub>2</sub>: Exploring Interface Mechanisms”**

Md Iftekharul Alam<sup>1</sup>, Shungo Nagata<sup>2</sup>, Rikiya Sumichika<sup>2</sup>, Junichi Tsuchimoto<sup>1</sup>, Akinobu Teramoto<sup>1,2</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering*, <sup>2</sup>*Graduate School of Advanced Science and Engineering, Hiroshima University*

**P20**

**“Evaluation of Distance Dependence of Received Power of Local 5G in Indoor Environments”**

Taketo Kakimoto<sup>1</sup>, Tomokazu Watanabe<sup>1</sup>, Tatsuya Hatagi<sup>1</sup>, Masataka Miyake<sup>1</sup>, Suguru Kameda<sup>1</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*

**P21**

**“Selective wet-POA Process for 4H-SiC CMOS Image Sensors”**

Katsuki Hachimata<sup>1</sup>, Tatsuya Meguro<sup>1</sup>, Akinori Takeyama<sup>2</sup>, Takeshi Ohshima<sup>2</sup>, Yasunori Tanaka<sup>3</sup>, Kazutoshi Kojima<sup>3</sup>, Shin-Ichiro Kuroki<sup>1</sup>

<sup>1</sup>*Research Institute for Semiconductor Engineering, Hiroshima University*, <sup>2</sup>*National Institutes for Quantum Science and Technology*, <sup>3</sup>*National Institute of Advanced Industrial Science and Technology*

**P22**

**“Atomic Layer Deposition Using a High Vapor Pressure Precursor and oxygen followed by Postdeposition Annealing for Area Selective Deposition”**

Rahman Gagi Tauhidur<sup>1,2</sup>, Shogo Okugawa<sup>1,2</sup>, Akinobu Teramoto<sup>1,2</sup>

<sup>1</sup>Quantum Matter Program, Advance Science and Engineering,

<sup>2</sup>Research Institute for Semiconductor Engineering, Hiroshima University

**P23**

**“Development of a molecular beam epitaxy system for the investigation of magnetic semiconductors/semimetals”**

Yuita Fujisawa<sup>1</sup>, Haruto Sato<sup>1</sup>, Kazuki Sumida<sup>1</sup>, Koji Miyamoto<sup>1</sup>, Masahiro Sawada<sup>1</sup>, Taichi Okuda<sup>1</sup>

<sup>1</sup>Hiroshima University/ Research Institute for Synchrotron Radiation Science

**P24**

**“USRP Implementation of Synchronized SS-CDMA Communications Function Using Wi-Wi: The Influence of Timing Offset in Broadband Environments”**

Toshiki OUCHI<sup>1</sup>, Serena AKASAKA<sup>1</sup>, Masataka MIYAKE<sup>1</sup>, Suguru KAMEDA<sup>1</sup>

<sup>1</sup>Research Institute for Semiconductor Engineering, Hiroshima University

**P25**

**“Silicon Ion Implantation Conditions for highly doped n-GaN”**

Iori Shinke<sup>1</sup>, Hayato Kosaka<sup>1</sup>, Jun-Ichi Tsuchimoto<sup>2</sup>, Yoshiteru Amemiya<sup>2</sup>, Akinobu Teramoto<sup>1,2,3</sup>

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**P26**

**“Estimation of 1/f noise variation in MOSFETs”**

Takuma Hamasaki<sup>1</sup>, Tomomi Ishikawa<sup>2</sup>, Akinobu Teramoto<sup>1,2,3</sup>

<sup>1</sup>Graduate School of Advanced Science and Engineering, Hiroshima University, <sup>2</sup>Research Institute for Semiconductor Engineering, Hiroshima University, <sup>3</sup>Research Institute for Synchrotron Radiation Science, Hiroshima University

**P27**

**“Effect of Ammonia Plasma Treatment on Interface Properties of ALD SiO<sub>2</sub>/SiC MOS Capacitors”**

An Li<sup>1</sup>

<sup>1</sup>Institute of Science Tokyo

**P28**

**“Anisotropic Topological Surface State Bands Induced by Electron Confinement”**

Ryohei Yamamoto<sup>1,2</sup>, Kazuki Sumida<sup>1,2</sup>, Yuita Fujisawa<sup>1,2</sup>, Hitoshi Sato<sup>1,2</sup>, Koji Miyamoto<sup>1,2</sup>, Taichi Okuda<sup>1,2</sup>

<sup>1</sup>HiSOR, <sup>2</sup>Hiroshima University

**P29**

**“Comparative Performance Analysis of OTFS and OFDM in High Doppler Shift Conditions for Q/V-Band LEO Satellite Communication”**

Ryo Arimura<sup>1</sup>, Masataka Miyake<sup>1</sup>, Suguru Kameda<sup>1</sup>

<sup>1</sup>Research Institute for Semiconductor Engineering, Hiroshima University

**P30**

**“Fundamental Investigation of Antenna Deployment Method in Antenna-Cluster-Centric Cell-Free Massive MIMO Systems”**

Kazuya Ogata<sup>1</sup>, Sijie Xia<sup>1</sup>, Masataka Miyake<sup>1</sup>, Suguru Kameda<sup>1</sup>, Fumiyuki Adachi<sup>2</sup>

<sup>1</sup>Research Institute for Semiconductor Engineering, Hiroshima University, <sup>2</sup>International Research Institute of Disaster Science, Tohoku University

**P31**

**“Bottom Electrode Material Selection for Ferroelectric AlScN Films”**

Hitomi Hasegawa<sup>1</sup>, Si-Meng Chen<sup>1</sup>, Takuya Hoshii<sup>1</sup>, Kazuo Tsutsui<sup>2</sup>, Hitoshi Wakabayashi<sup>2</sup>, Kuniyuki Kakushima<sup>1</sup>

<sup>1</sup>School of Engineering, Institute of Science Tokyo, <sup>2</sup>Institute of Integrated Research, Institute of Science Tokyo

**P32**

**“Design Strategies for Consolidated Metal-Filled Layout in High-Frequency CMOS Integrated Circuits”**

Yudai Miyoshi<sup>1</sup>, Satoshi Tanaka<sup>1</sup>, Takeshi Yoshida<sup>1</sup>, Minoru Fujishima<sup>1</sup>

<sup>1</sup>Hiroshima University

**P33**

**“Design of Broadband CMOS Differential Amplifier with Flat Gain Characteristics”**

Koki Mochida<sup>1</sup>, Satoshi Tanaka<sup>1</sup>, Takeshi Yoshida<sup>1</sup>, Shuhei Amakawa<sup>1</sup>, Minoru Fujishima<sup>1</sup>

<sup>1</sup>Hiroshima University

**P34**

**“Miniaturization and Broadband Operation of CMOS D-band Wilkinson Power Divider”**

Leshan Xu<sup>1</sup>, Satoshi Tanaka<sup>1</sup>, Takeshi Yoshida<sup>1</sup>, Minoru Fujishima<sup>1</sup>

<sup>1</sup>Graduate School of Advanced Science and Engineering, Hiroshima University

**P35**

**“Design of Phase Shifter for 300 GHz  
Transceiver using 40nm CMOS”**

Zhen Yan<sup>1</sup>, Satoshi Tanaka<sup>1</sup>, Takeshi Yoshida<sup>1</sup>, Minoru  
Fujishima<sup>1</sup>

<sup>1</sup>*Hiroshima University*